



Atty. Docket No.: 005040/TCG/PMD/LE (BSTZ Ref. No.: 004887.P522) Patent  
Confirmation No.: 7268

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Don E. Curry, et al.

Application No: 09/828,067

Filed: April 6, 2001

For: A WAFER PROCESSING APPARATUS  
HAVING A CHAMBER WITH AN UPPER  
WALL HAVING GAS SUPPLY OPENINGS  
FORMED THEREIN WHICH PROMOTE  
MORE EVEN PROCESSING OF A WAFER

) Examiner: Zervigon, Rudy

) Art Unit: 1763

Mail Stop: RCE  
Commissioner For Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION  
ACCOMPANYING A REQUEST FOR CONTINUED EXAMINATION (RCE)

Dear Examiner:

In response to the Final Office Action mailed April 5, 2006, please enter the following amendments and consider the following remarks. A Request Continued Examination (RCE) is filed herewith.

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FIRST-CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail with sufficient postage in an envelope addressed to Mail Stop: Amendment, Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450, on:

October 5, 2006  
Date of Deposit

Carrie Boccaccini  
Name of Person Mailing Correspondence

  
Signature

October 5, 2006  
Date

Inventor(s): Don E. Curry et al.  
Application No.: 09/828,067

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Examiner: Zervigon, Rudy  
Art Unit: 1763